

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

1300 I STREET, N. W.
WASHINGTON, DC 20005-3315

202 • 408 • 4000
FACSIMILE 202 • 408 • 4400

WRITER'S DIRECT DIAL NUMBER:

(202) 408-4024

December 21, 1999

ATLANTA
404•653•6400
PALO ALTO
650•849•6600

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jc658 U.S. PTO

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jc511 U.S. PTO
09/469190
TOKYO
011•813•3431•6943
BRUSSELS
011•322•646•0353

ATTORNEY DOCKET NO.: 04329.2210

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

New U.S. Patent Application
Title: SEMICONDUCTOR DEVICE AND
METHOD OF MANUFACTURING THE SAME
Inventors: 1) Katsuhiko HIEDA and 2) Kazuhiro EGUCHI

Sir:

We enclose the following papers for filing in the United States Patent and Trademark Office in connection with the above patent application.

1. A check for \$932 representing a \$892 filing fee and \$40 for recording the Assignment.
2. Application - 51 pages, including 4 independent claims and 23 claims total.
3. Drawings - 15 sheets of formal drawings, containing 53 figures.
4. Declaration and Power of Attorney.
5. Recordation Form Cover Sheet and Assignment to Kabushiki Kaisha Toshiba.

Applicants claim the right to priority based on Japanese Patent Application Nos. 10-365491, filed on December 22, 1998 and 11-336605, filed on November 26, 1999.

Please accord this application a serial number and filing date and record and return the Assignment to the undersigned.

RVB/FPD/sci
Enclosures